

Fig. 1A  
(Prior Art)

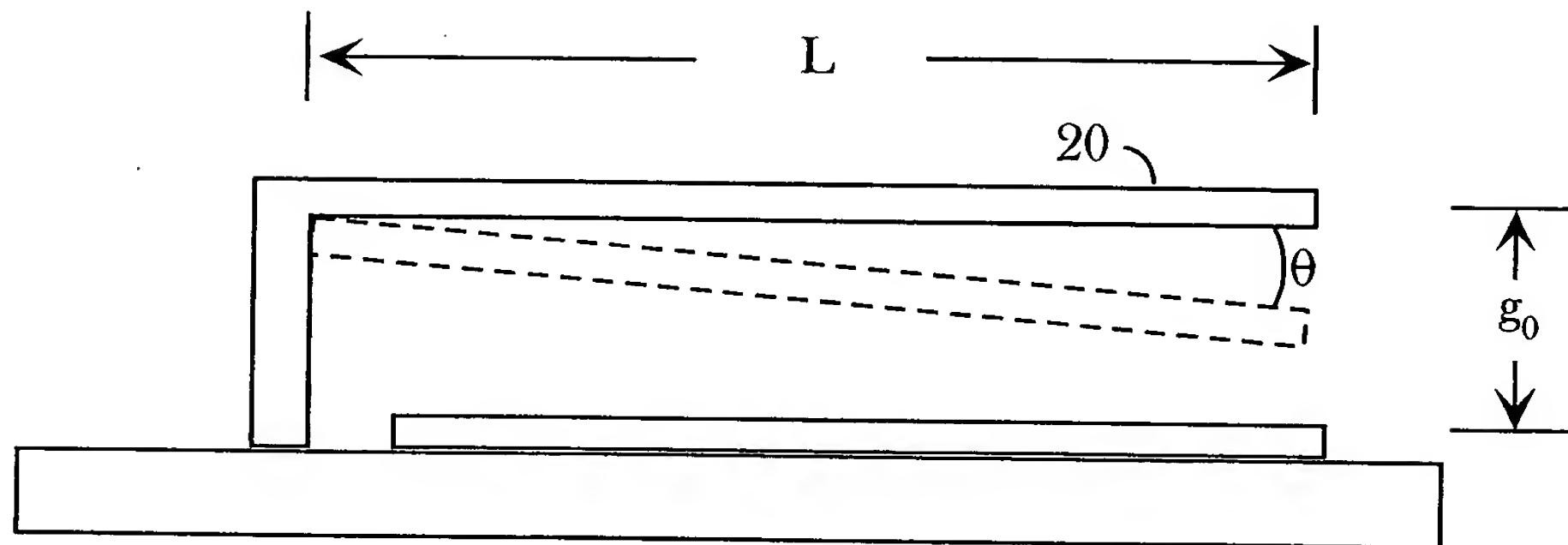


Fig. 1B  
(Prior Art)

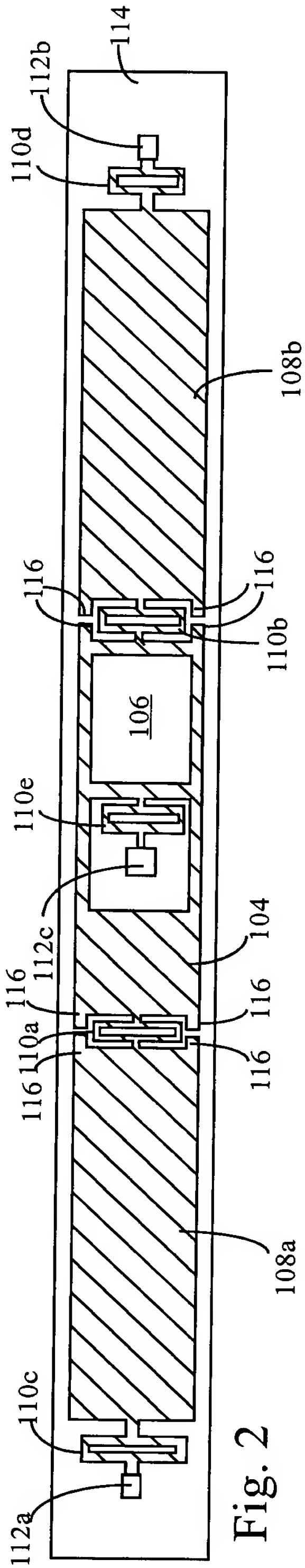


Fig. 2

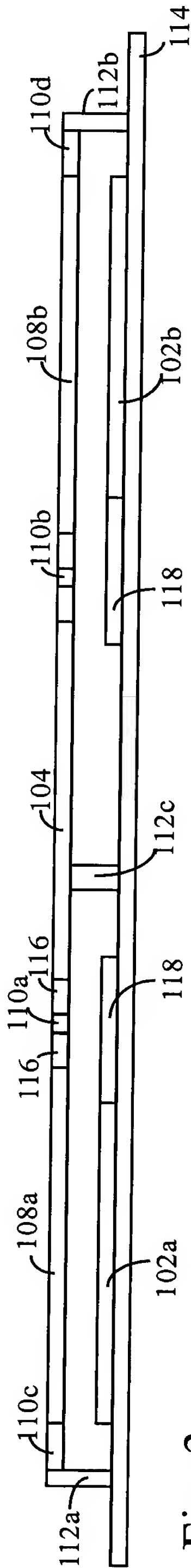


Fig. 3

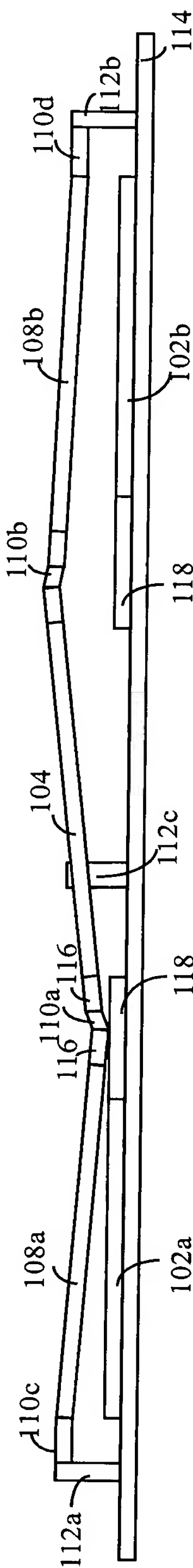


Fig. 4

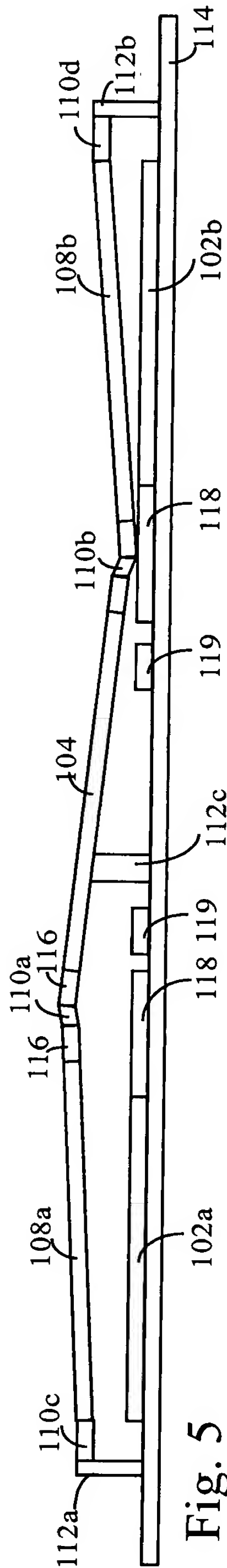


Fig. 5



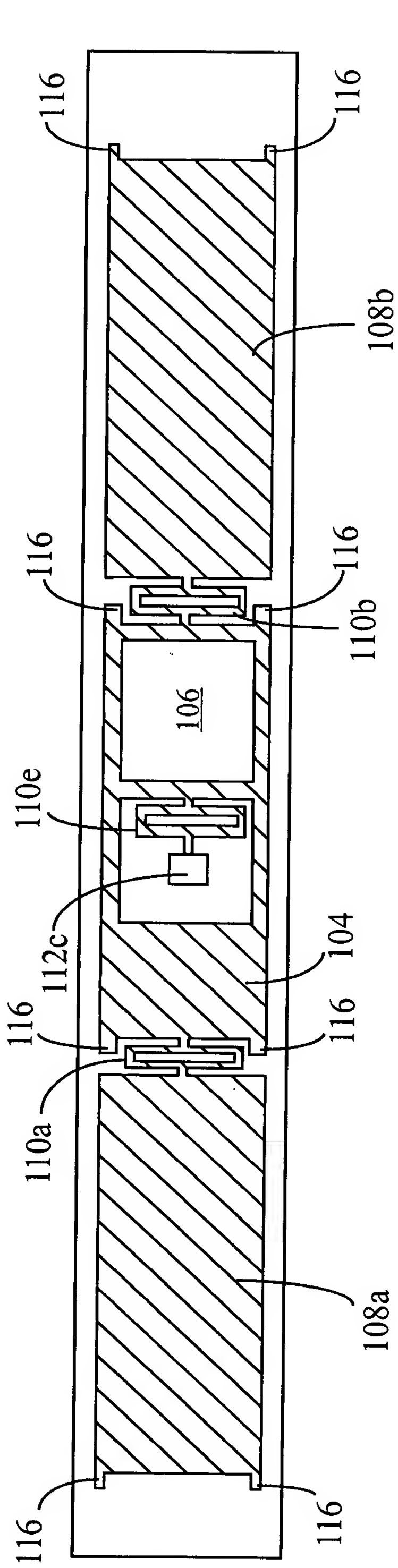


Fig. 8

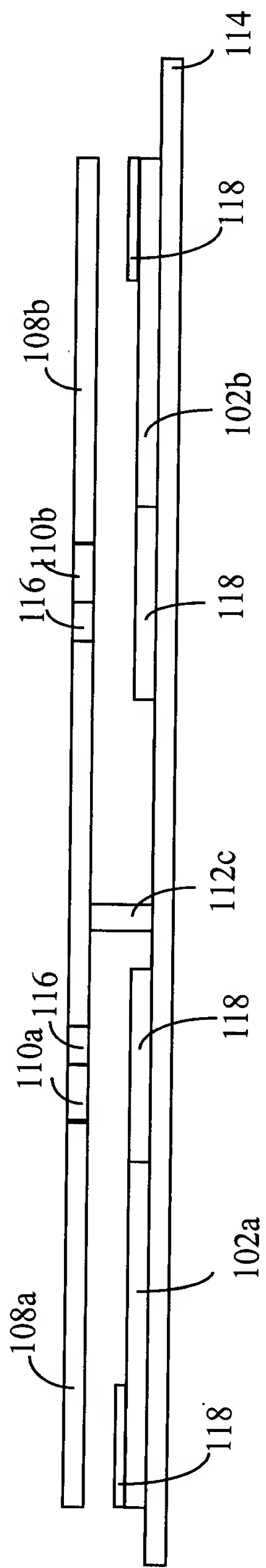


Fig. 9

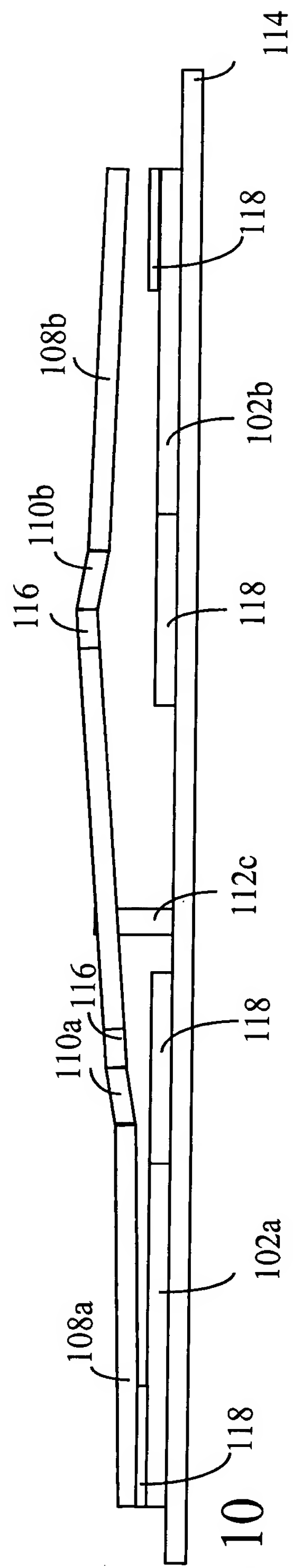


Fig. 10

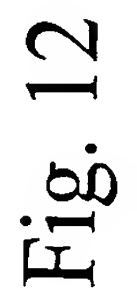
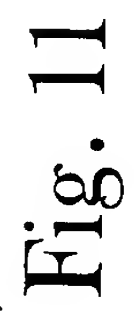


Fig. 13

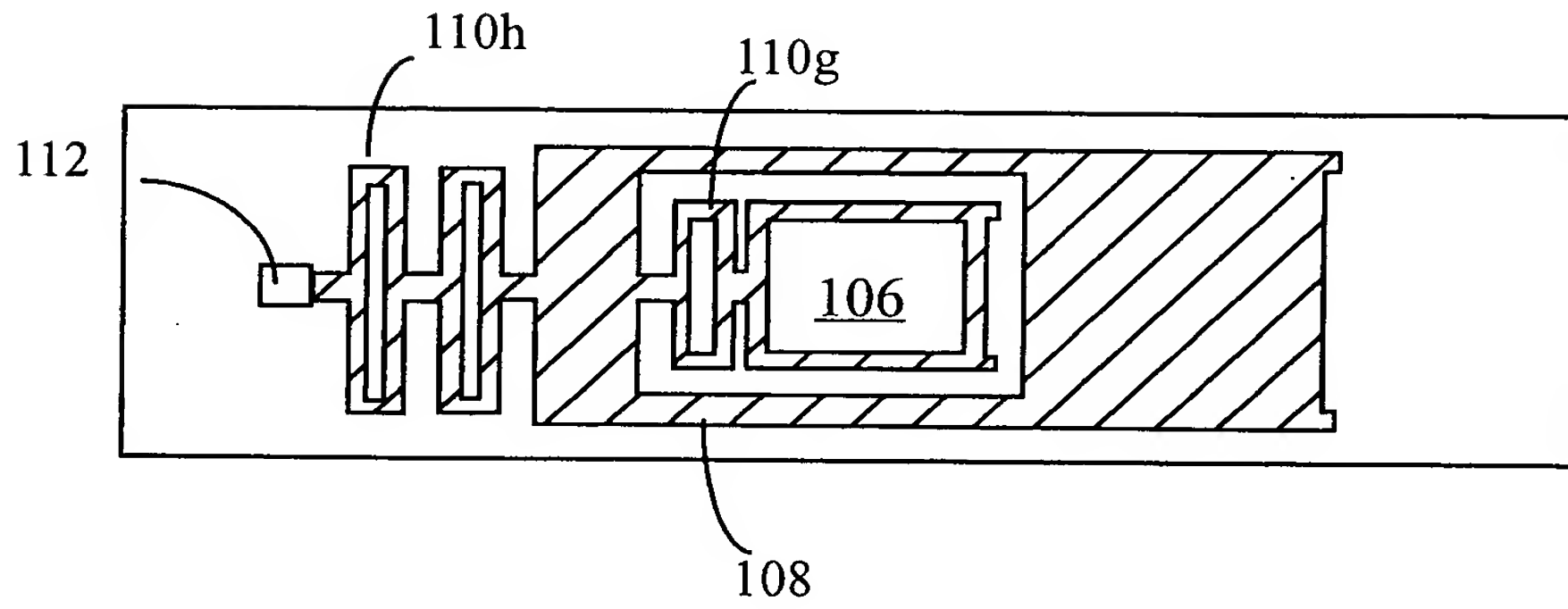
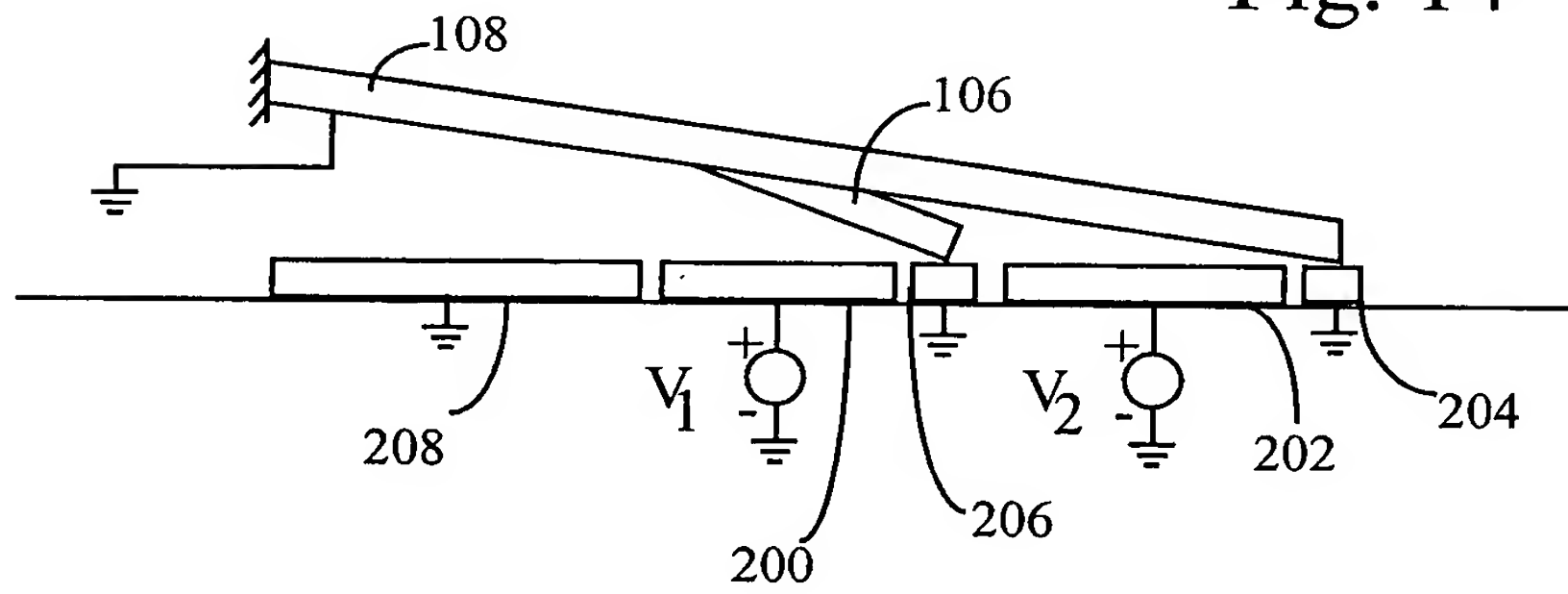
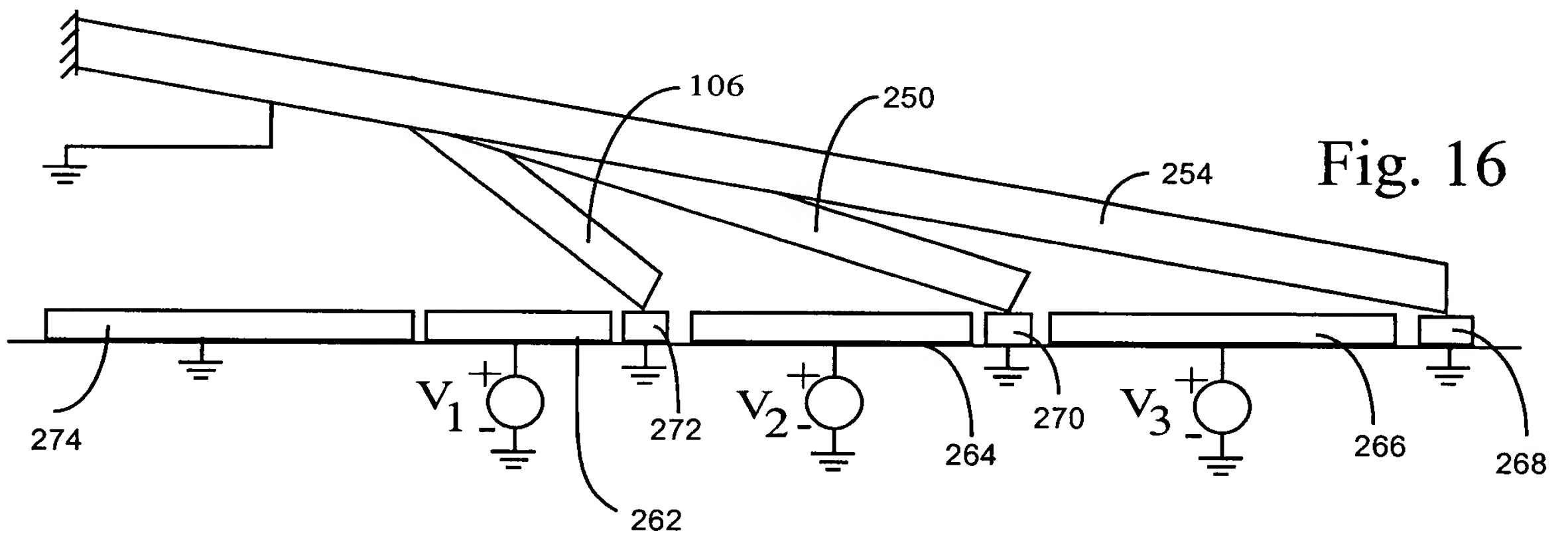
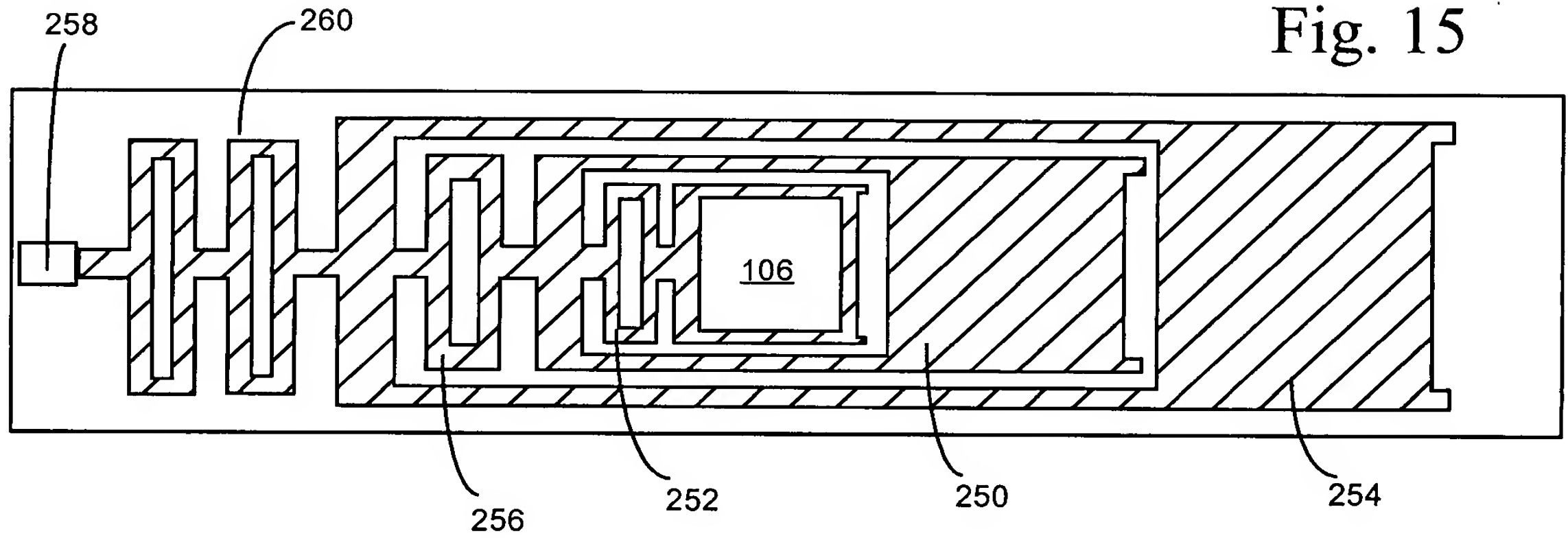


Fig. 14





Title: Parallel Plate Electrostatic Actuation of MEMS Mirrors  
 Appl: William A. Clark  
 Appl: Unknown  
 Filing Date: March 6, 2002  
 Express Mail No.: EL 073878046 US

Docket: AIMI-01834USC  
 Atty: Brian I. Marcus  
 Phone: (415) 369-9660

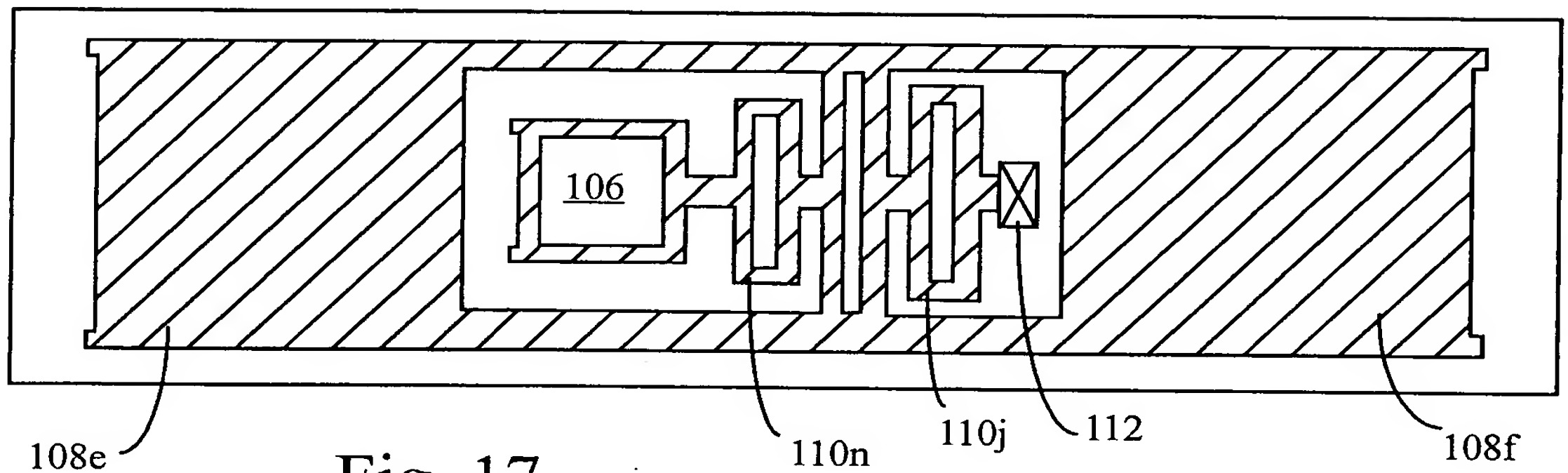
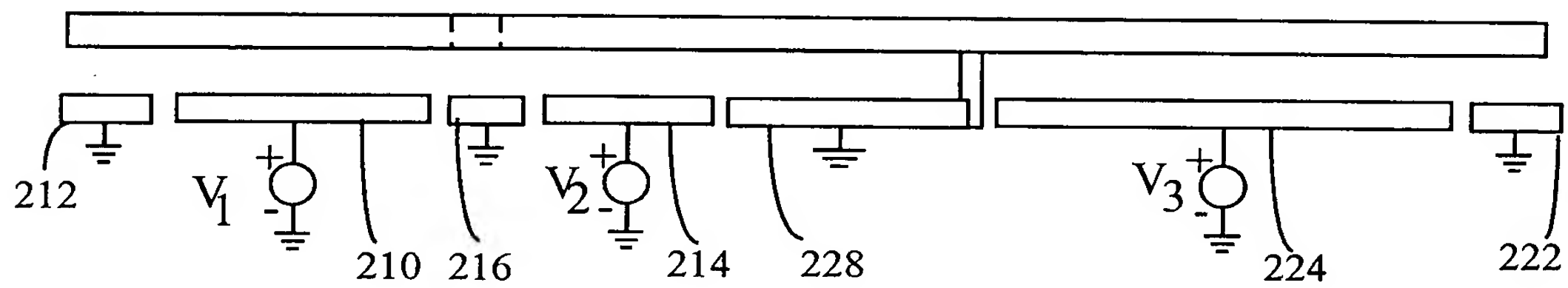


Fig. 17

Fig. 18





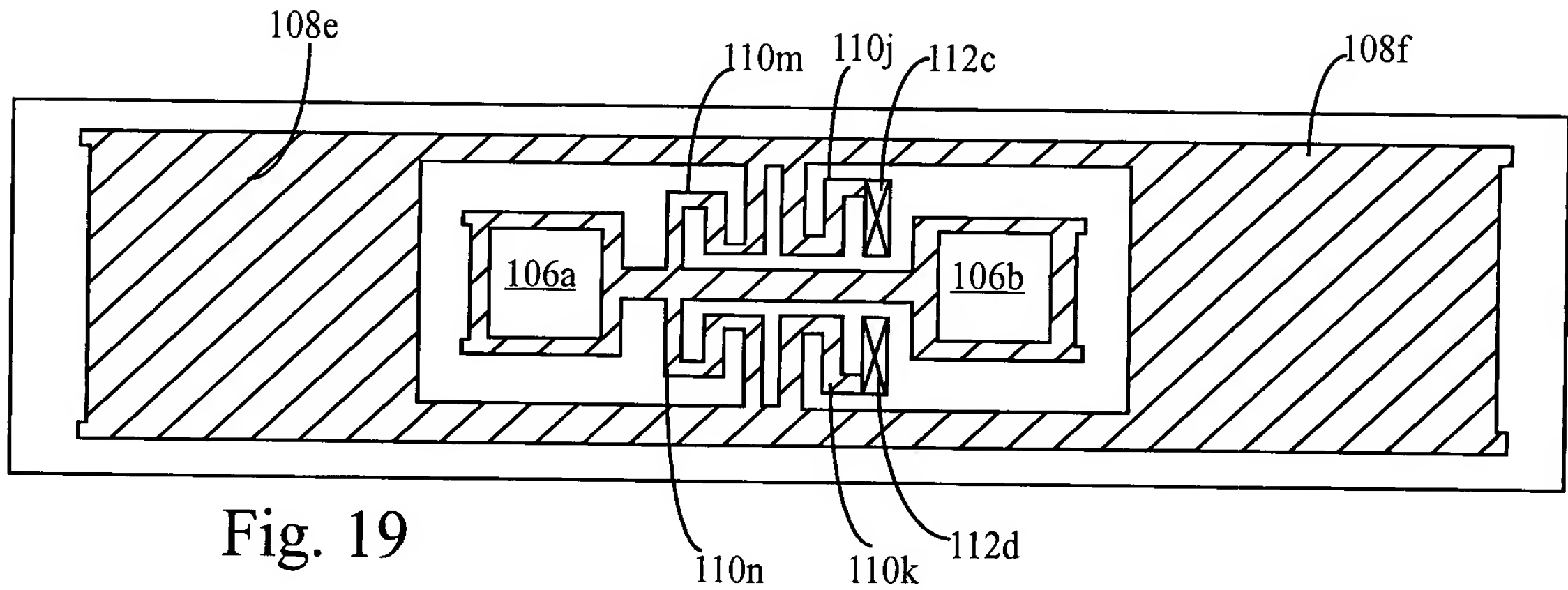


Fig. 19

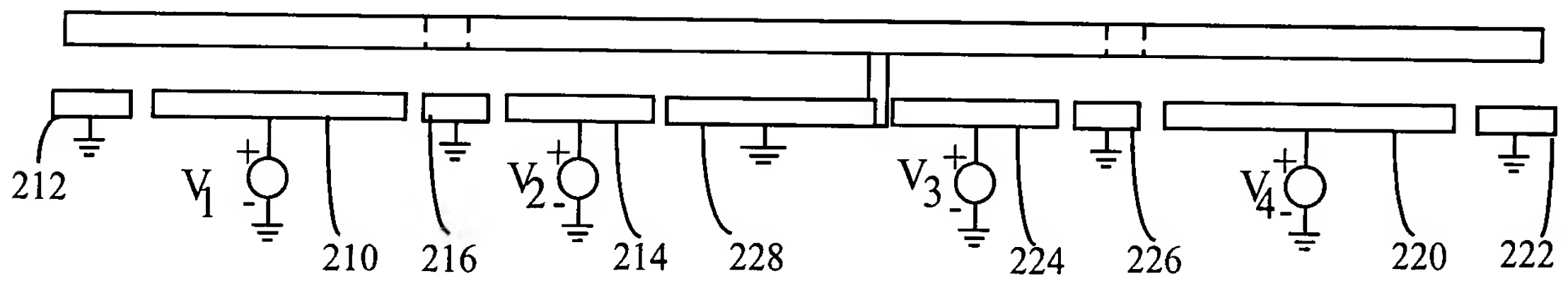


Fig. 20

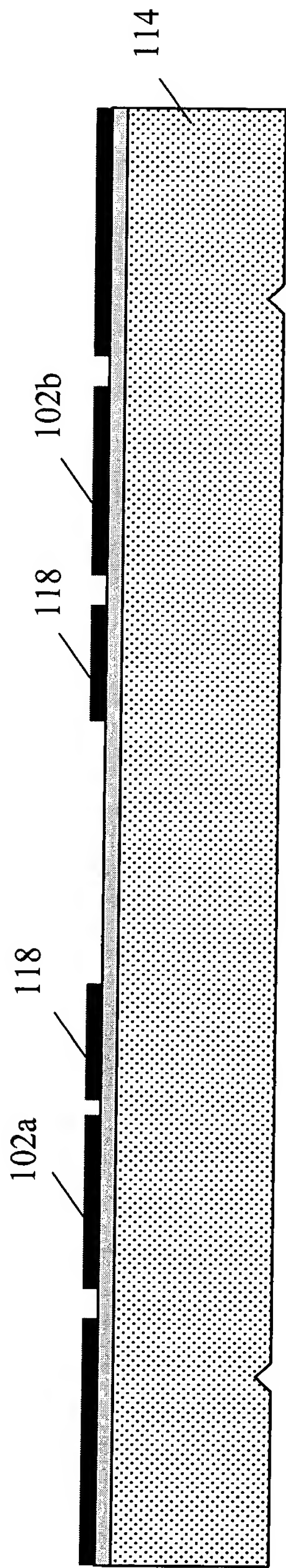


Fig. 21

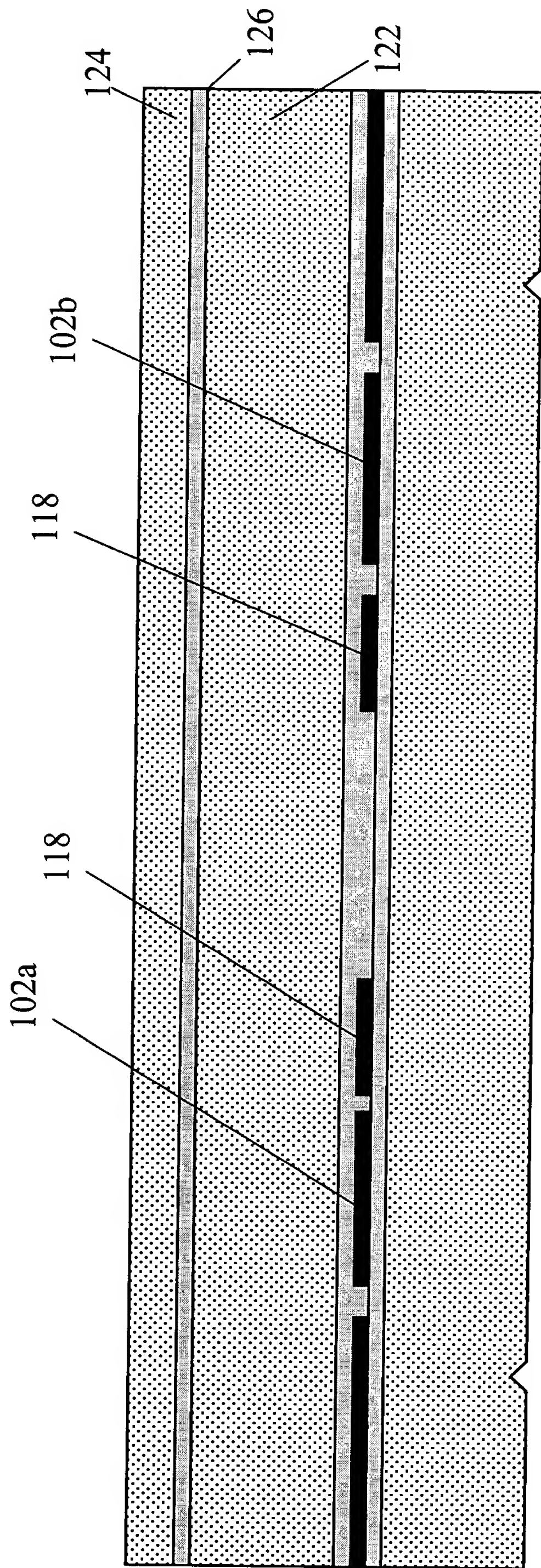


Fig. 22

- poly
- single crystal silicon
- oxide
- resist
- diffusion
- metal
- gold

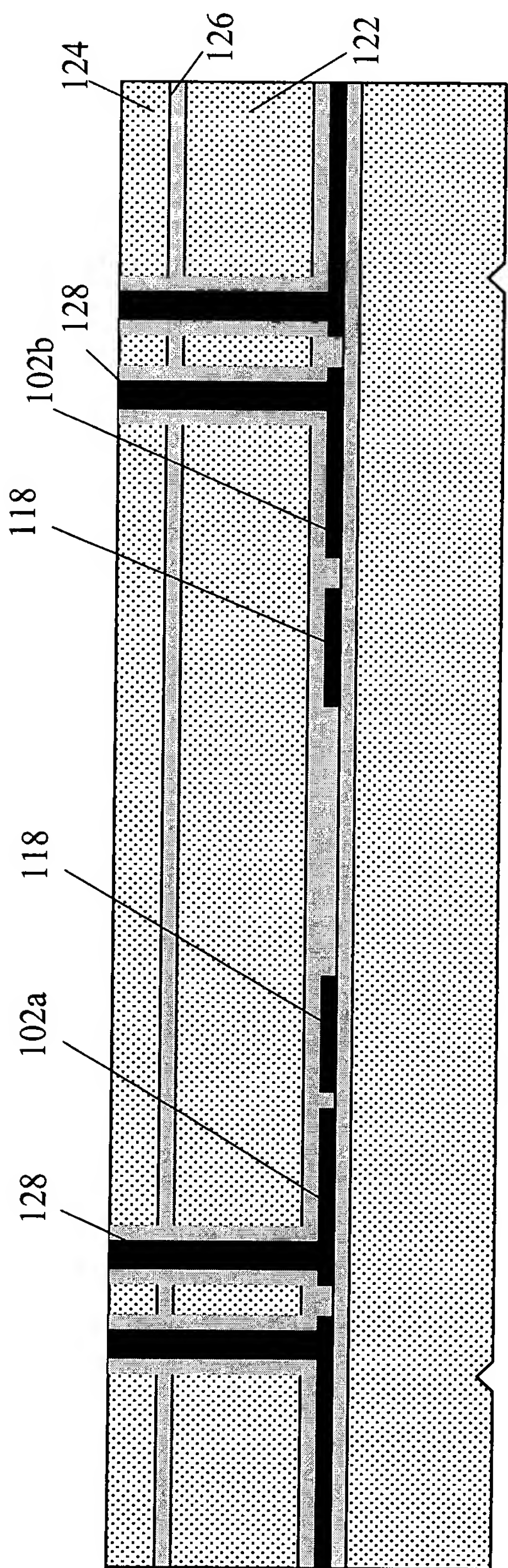


Fig. 23

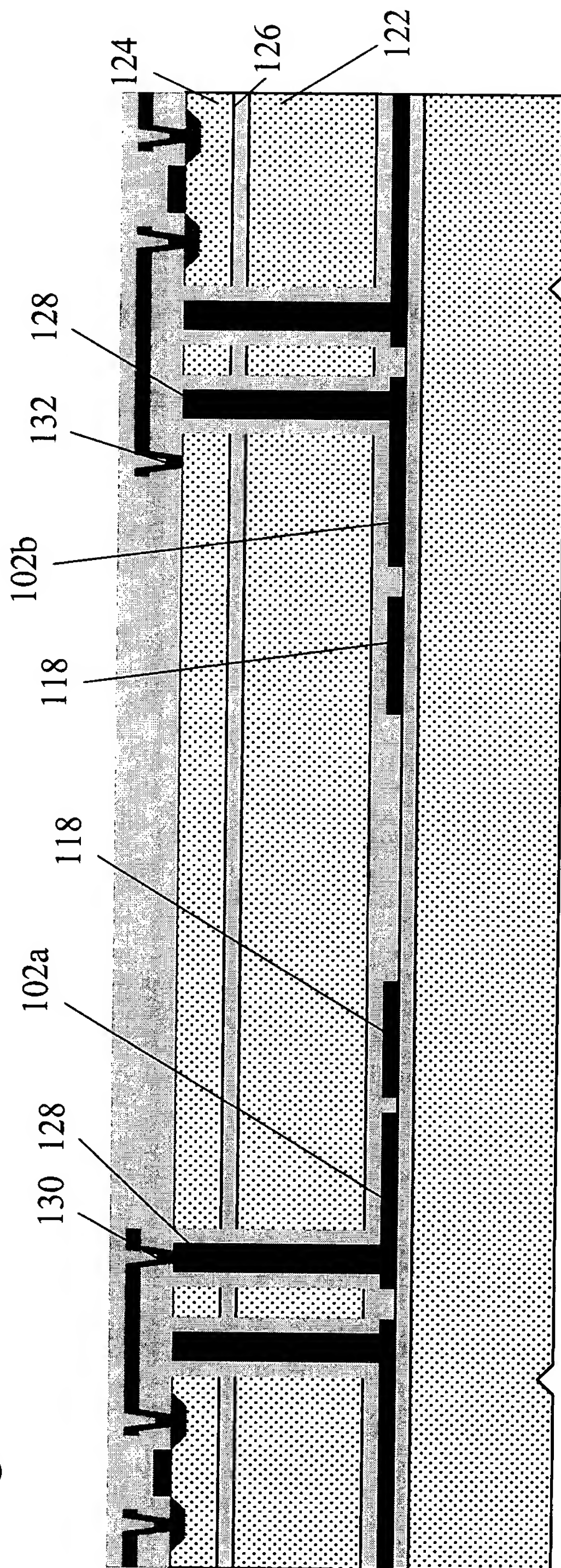


Fig. 24



